

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTORSHIP BADDING, John V. et al.
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ATTORNEY DOCKET NO. SO03-P05
TITLE: **SYNTHESIS OF GERMANIUM SULPHIDE AND RELATED
 COMPOUNDS**

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

This Supplemental Information Disclosure Statement is being filed in compliance with 37 C.F.R. § 1.97(b)(1) (i.e., within three months of the filing date of a national application other than a continued prosecution application under 37 C.F.R. § 1.53(d)). Your attention is directed to the references listed on the attached Form PTO-1449. No admission is made regarding whether the submitted references are prior art.

Respectfully submitted,

John V. BADDING, Daniel William HEWAK,
and Chung-Che HUANG, assignors to the
University of Southampton, all Applicants

Dated: May 2, 2006

By: 

John S. Reid
Attorney and agent for Applicant
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STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

Application Number	10/575,199
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First Named Inventor	BADDING, John V.
Art Unit	
Examiner Name	
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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	A	D. Sheel and M. Pemble, "Atmospheric Pressure CVD Coatings on Glass", ICCG4 November 2002	✓
	B	Ohta T, Akahira N, Ohara S, Satoh I: "High-Density Phase Change Optical Recording", Optoelectronics 1995, 10:361-380	✓
	C	I. P. Kotsalas and C. Raptis, "High-temperature Structural Phase Transitions of GexS1-x Alloys Studied by Raman Spectroscopy", Physics Review B, Vol. 64, 11 SEP. 2001	✓
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